

(11)Publication number:

(43) Date of publication of application: 23.10.1998

(51)Int.CI.

**G03F** 7/004 **G03F** G03F GO3F

G03F 7/039 H01L 21/027

(21)Application number: 09-149744

(71)Applicant: NIPPON TELEGR & TELEPH CORP

(22)Date of filing:

06.06.1997

(72)Inventor: ISHII TETSUYOSHI

TAMAMURA TOSHIAKI **NOZAWA HIROSHI** KURIHARA KENJI

(30)Priority

Priority number: 08166607

Priority date: 07.06.1996

Priority country: JP

08242560 09 38538

27.08.1996

07.02.1997

JP

JP

## (54) RESIST COMPOSITION AND ITS PRODUCTION

## (57)Abstract:

PROBLEM TO BE SOLVED: To obtain a resist compsn. which enables highly accurate processing by preparing a resist compsn. consisting of a resist and fine particles comprising aggregation of carbon atoms as the main constituent element mixed in the resist.

SOLUTION: This resist compsn. contains a resist and fine particles comprising aggregation of carbon atoms as the main constituent element mixed in the resist. Intrusion of etching reaction seeds into the film is inhibited and the etching durability of the resist film is enhanced because vacancies among the resists are filled with the fine particles, which increases the density of the resist film, and because the fine particles is composed of aggregation of carbon atoms as the main constituent element having high etching durability. Not only the enhancement of the etching durability, but intrusion of a developer into the film is inhibited and the contrast of the resist pattern is enhanced. As for the aggregation of carbon atoms as the main structural element, a fullerene can be used.

## **LEGAL STATUS**

[Date of request for examination]

18.10.2000

[Date of sending the examiner's decision of

rejection]

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Patent number]

3515326

[Date of registration]

23.01.2004

[Number of appeal against examiner's decision of rejection]

[Date of requesting appeal against examiner's decision of rejection]

'[Date of extinction of right]

Copyright (C); 1998,2003 Japan Patent Office